Gases and Facilities Japan Joint TC Chapter Meeting

In conjunction with SEMICON Japan 2026

Thursday, December 10, 2026

Room 904, TFT Building East 9F, Tokyo, Japan / Official Virtual TC Chapter Meeting (Hybrid)

9:00 AM - 12:00 PM JST

AGENDA

1 Welcome/Call to Order

1.1 Introductions

1.2 Required Elements (Membership Requirements, Antitrust and Intellectual Property Reminders, and Effective Meeting Guidelines)

1.3 Agenda Review

2 Review of Previous Meeting Minutes

3 Technical Committee Award

4 Liaison Report

4.1 Japan Regional Standards Committee (JRSC)

4.2 Global Coordinating Subcommittee (GCS)

4.3 Europe TC Chapter

4.4 North America TC Chapter

4.5 Korea TC Chapter

5 Staff Report

6 Ballot Review

6.1 Doc.#7479, Reapproval of SEMI F1-0521, Specification for Leak Integrity of High-Purity Gas Piping Systems and Components

6.2 Doc.#7481 Line Item Revision to SEMI F44-0325, Specification for Machined Stainless Steel Weld Fittings

7 Subcommittee & Task Force Reports

7.1 Gases Japan TC Chapter

7.1.1 5-Year-Review Task Force

7.2 Facilities Japan TC Chapter

7.2.1 F1 Revision Task Force

7.2.2 E137 Revision Task Force

7.2.3 5-Year-Review Task Force

8 Old Business

8.1 Project Period Review

8.2 5-Year-Review

9 New Business

10 Action Item Review

10.1 Open Action Items

Item #	*Assigned to*	*Details*
G+F_20260529-01	SEMI Staff	To forward the ballot review results of Doc.#7297A to the A&R SC for procedural review.
G+F_20260529-02	SEMI Staff	To submit Letter Ballot for Reapproval of SEMI F1 in Cycle 6.
G+F_20260529-03	5-year Review TF	To submit Letter Ballot for SEMI F44 Line Item Revision in Cycle 6 or Cycle 7.
G+F_20260529-04	E137 Revision TF	To confirm the commenter (Clark Cao from NAURA) whether he has some suggestions for the document.

10.2 New Action Items

Item #	*Assigned to*	*Details*

11 Next Meeting and Adjournment

11.1 The next meeting is scheduled for <date> at <event/location>.